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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of

Application Number 09/853,370
Filing Date 05-11-2001
First Named Inventor Donald S. Gardner
Art Unit 2832
Examiner Name Not yet assigned

Attorney Docket Number 42390P11265

5			U.S. PATI	ENT DOCUMENTS	
Zxamirer Initiate	Cite No.1	Document Number Number - Kind Code <sup>2</sup> (if known	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
WIN		US- 3881244	05-06-1975	Kendall	
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TIN		US- 5877533	03-02-1999	Arai et al.	
		US-			

	FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code 3 - Number 4 - Kind Code 5 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т6				
TIN		EP 0 725 407 - A1	08-07-1996	IBM Corporation						
TEN		WO 01/39220 - A1	05-31-2001	Intel Corporation						
752 152 152	/	JP 07-272932	10-20-1995	Canon Inc.						
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of

Complete if Known 09/853,370 Application-Number 05-11-2001 Donald S. Gardner First Named Inventor 2832 **Group Art Unit** Not yet assigned **Examiner Name** Attorney Docket Number 42390P11265

I			OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
	Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher_city_and/or_country_where published	T <sup>2</sup>
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Complete if Known Substitute for form 1449B/PTO 09/853,370 **Application Number** INFORMATION DISCLOSURE 05-11-2001 Filing Date Donald S. Gardner STATEMENT BY APPLICANT **First Named Inventor** 2832 **Group Art Unit** Not yet assigned (use as many sheets as necessary) **Examiner Name** Attorney Docket Number 42390P11265 of Sheet

Examiner	Cite	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the	١,
Initials	No. <sup>1</sup>	item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher_city and/or country where published.	Ľ
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Examiner Signature Date Considered 10/19/or				
	1	1 Variable		10/19/02

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				Application Number	09/853,370	
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Sheet	4	of	4	Attorney Docket Number	42390P11265	

	include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
OIP	ERIK DRANDON, "System on A Chip Integrated rassive Components (µIRS)"
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